



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of:) Attorney Docket: 4425-154

LAI ET AL.

) Group Art Unit: 2814

Serial No.: 09/888,494

) Examiner: Long Pham

Filed: June 26, 2001

)

For: METHOD FOR FORMING A METAL OXIDE SEMICONDUCTOR
TYPE FIELD EFFECT TRANSISTOR

AMENDMENT UNDER 37 CFR 1.116

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

This paper is in response to the Official Action dated December 3, 2002. In that Official Action, Claims 1-18 are rejected under 35 U.S.C. §103(a). Kindly amend the application in accordance with the following particulars:

RECEIVED

MAR -6 2003

TECHNOLOGY CENTER 2800

775/B
(NPI
Marisha
3/12/03